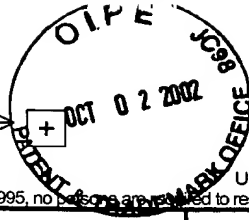


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Application Number	09/878,189
Filing Date	June 12, 2001
First Named Inventor	Guoyi FU et al.
Group Art Unit	UNASSIGNED
Examiner Name	Unassigned
Attorney Docket Number	EMI 21

### U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
MDV		3,497,367		Gaskin et al.	02/24/70	
		3,138,475		Schroder et al.	6/23/64	
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		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
MDV		DE	4316814	A1	Dallmann et al.	11/24/94		
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		EP	0216278	A2	Unger et al.	04/10/98		

### OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
MDV		JOANNOPOULOS, et al., "Photonic Crystals, Molding the Flow of Light, 1995, pp. 1-137	
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Examiner Signature

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Date Considered

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